

U.S. Department of Commerce, Patent and Trademark Office (PTO Form 1449 modified)				Docket No. AMAT/8284/CMPW-C/RKK		Serial No. 10/676,182		
LIST OF PATENTS AND PUBLICATIONS CITED BY APPLICANT (Use several sheets if necessary)				Applicant Verhaverbeke		Confirmation No.: Unknown		
Examiner Unknown				Filing Date September 30, 2003		Group Unknown		
U.S. Patent Documents								
*Examiner Initial		Document Number	Issue Date	Applicant(s) Name	Class	Subclass	Filing Date If Appropriate	
La	A1	5,326,490	07/05/94	Mori, et al.	252	79.2	11/15/91	
	A2	5,294,570	03/15/94	Fleming, Jr., et al.	437	239	01/29/92	
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La	A4	4,220,706	09/02/80	Spak	430	318	05/10/78	
	A5							
	A6							
	A7							
	A8							
	A9							
Foreign Patent Documents								
*Examiner Initial		Document Number	Date	Country	Class	Subclass	Translation	
							YES	NO
La	B1	02/10480	02/07/02	WO	C23G	1/00	<input type="checkbox"/>	<input type="checkbox"/>
	B2	01/24244	04/05/01	WO	H01L	21/311	<input type="checkbox"/>	<input type="checkbox"/>
	B3	0 918 081 A1	05/26/99	EP	C09K	13/08	<input type="checkbox"/>	<input type="checkbox"/>
	B4	0 477 504 A1	04/01/92	EP	H01L	21/306	<input type="checkbox"/>	<input type="checkbox"/>
La	B5	7183287	07/21/95	JP	H01L	21/308	<input type="checkbox"/>	<input type="checkbox"/>
OTHER ART								
*Examiner Initial		Including Author, Title, Date, Pertinent Pages, Etc.						
La	C1	Archer, et al. "Real Fab Comparisons Reveal Advantage to Inorganic-based Polymer Removal," Solid State Technology - Semiconductor Manufacturing and Wafer Fabrication, December 2002						
	C2	Archer, et al. "Removing Postash Polymer Residue from BEOL Structures Using Inorganic Chemicals," Micro, June 2001						
	C3	Verhaverbeke, et al., Improved Rinsing Efficiency After SPM (H ₂ SO ₄ /H ₂ O ₂) by Adding HF, Proceedings of the Second International Symposium on Ultra-Clean Processing of Silicon Surfaces (1994)						
La	C4	Khan, "Use of Lithographically Defined Metal Masks in Selective Chemical Etching of Patterns in Thin Films: Microelectronic Applications," Thin Solid Films, 206 (1991) 269-274						
Examiner Schauky					Date Considered 7/20/05			
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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PTO/SB/08a (08-03)

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Sheet 1

of 1

Application Number

10/676,182

Filing Date

September 30, 2003

First Named Inventor

Verhaverbeke

Group Art Unit

1746

Examiner Name

Unknown

Attorney Docket Number

AMAT/8284/CMP/W-C/RKK

Submission Date

September 23, 2004

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
JA	A1	US-6605230 B1	08/12/2003	Liaw, et al.	
JA	A2	US-6273959 B1	08/14/2001	Oonishi, et al.	
	A3				
	A4				
	A5				
	A6				
	A7				
	A8				
	A9				
	A10				
	A11				
	A12				
	A13				
	A14				
	A15				
	A16				
	A17				
	A18				

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
Dea	C1	International Search Report for PCT/US2004/003856 (AMAT/8284-PCT) dated July 28, 2004	
Se	C2	Written Opinion of the International Searching Authority for PCT/US2004/003856 (AMAT/8284-PCT) dated July 28, 2004	

Examiner

Schandley

Date Considered

7/20/05

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First Named Inventor	Verhaverbeke
Group Art Unit	1746
Examiner Name	Unknown
Attorney Docket Number	AMAT/8284/CMP/W-C/RKK
Submission Date	September 28, 2004

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
JA	A1	US-6630074 B1	10/07/2003	Rath, et al.	
	A2	US-5780363	07/14/1998	Delehanty, et al.	
	A3	US-4100014	07/11/1978	Kuhn-Kuhnenfeld, et al.	
	A4	US- 200300209514 A1	11/13/2003	Ramachandran, et al.	
	A5				
	A6				
	A7				
	A8				
	A9				
	A10				
	A11				
	A12				
	A13				
	A14				
	A15				

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ³
		Country Code ² -Number ³ -Kind Code ⁴ (if known)				
JA	B1	TW 0296405	01/21/1997	Jaw, et al.		
	B2	JP 58030135	02/22/1983	Shiyuichi		
	B3	JP 52033847	03/15/1977	Masaaki, et al.		
	B4	UK 989,025	04/14/1965			

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
JA	C1	Kelly, J.J., et al., "Electrochemical Aspects of the Beveling of Sputtered Permalloy Films," J. Electrochem Soc.: Electrochemical Science and Technology Vol. 125, No. 6 (June 1978) pp. 860-865	

Examiner

J. Chaudhary

Date Considered

7/20/05

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